

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 89518
	:	
Mou-Shiung Lin, et al.	:	Confirmation Number: 6138
	:	
Application No.: 09/523,990	:	Group Art Unit: 2887
	:	
Filed: March 13, 2000	:	Examiner: Daniel I. Walsh
	:	
For: METHOD OF MANUFACTURE AND IDENTIFICATION OF SEMICONDUCTOR CHIP MARKED FOR IDENTIFICATION WITH INTERNAL MARKING INDICIA AND PROTECTION THEREOF BY NON-BLACK LAYER AND DEVICE PRODUCED THEREBY		

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE / AMENDMENT

Sir:

In response to the final Office Action dated May 23, 2012, a Request for Continued Examination being filed herewith, entry and consideration of the following amendments and remarks are respectfully requested:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

An **Appendix** is attached after the last page, which shows the status of related cases.